| CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)  |  |                                    |         | Docket No.   |
|--|--|------------------------------------|---------|--|
| Applicant(s): Anderson et al.  | ·                                      |                                    | <u></u> | BUR920030031US1  |
| Application No.  | Filing Date                            | Examiner                           |         | Group Art Unit   |
| 10/604,116   | 06/26/2003                             | Joannie A. Garcia                  |         | 2823   |
| Invention: METHOD OF FO  | ORMING FREESTANDING                    | SEMICONDUCTOR LAYER                |         | RECEIVED<br>ENTRAL FAX CENTER  |
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| I hereby certify that this Amendment in 11 pgs.  |  |                                    |         |  |
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| Dorothea Rubbone (Typed or Printed Name of Person Signing Certificate)   |  |                                    |         |  |
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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: Anderson et al.

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2823

Filed:

06/26/2003

Docket No.: BUR920030031US1 (IBMB-0028)

Examiner:

Joannie A. Garcia

Title: METHOD OF FORMING

FREESTANDING SEMICONDUCTOR

LAYER

RECEIVED CENTRAL FAX CENTER

AUG 2 3 2005

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

**AMENDMENT** 

Sir:

## INTRODUCTORY COMMENTS I.

In response to the Office Action of May 27, 2005, please amend the above-referenced patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of this paper.

Remarks begin on page 9 of this paper.

10/604,116

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